Monday, October 4, 2021

- Alex of asleins

5.2 A p-type silicon material is to have a conductivity of $\sigma = 1.80 \, (\Omega \text{-cm})^{-1}$. If the mobility values are $\mu_n = 1250 \text{ cm}^2/\text{V-s}$ and $\mu_p = 380 \text{ cm}^2/\text{V-s}$, what must be the acceptor impurity concentration in the material?

$$N_{\rm or} = \frac{\sigma}{e_{\mu_{\rm p}}} = \frac{1.80}{1.6 \times 10^{19} (380)} = \frac{2.96 \times 10^{16}}{\text{cm}^3}$$

5.6 Consider a homogeneous gallium arsenide semiconductor at T = 300 K with $N_d = 10^{16} \,\mathrm{cm}^{-3}$ and $N_a = 0$. (a) Calculate the thermal-equilibrium values of electron and hole concentrations. (b) For an applied E-field of 10 V/cm, calculate the drift current density. (c) Repeat parts (a) and (b) if $N_d = 0$ and $N_a = 10^{16}$ cm⁻³.

$$N_n = \frac{N_J - N_a}{2} + \sqrt{\left(\frac{N_d - N_a}{2}\right)^2 + n_i^2}$$

$$n_{n} = \frac{10^{16} - 0}{2} + \sqrt{\frac{10^{16} - 0}{2}} + \frac{1.8 \times 10^{6}}{1.8 \times 10^{6}}$$

$$P_{n} = \frac{n_{1}^{2}}{n_{n}} = \frac{(1.8 \times 10^{6})^{2}}{10^{16}} = \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}} + \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}}$$

$$D_{n} = \frac{n_{1}^{2}}{n_{n}} = \frac{(1.8 \times 10^{6})^{2}}{10^{16}} = \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}} + \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}}$$

$$D_{n} = \frac{10^{16}}{2} + \sqrt{\frac{10^{16}}{2} + \frac{1.8 \times 10^{6}}{10^{16}}} = \frac{10^{16}}{3.24 \times 10^{4}} + \frac{10^{16}}{3.24 \times 10^{4}} = \frac{10^{16}}{3.24 \times 10^{4}} + \frac{10^{16}}{3.24 \times 10^{4}} = \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}} + \frac{3.24 \times 10^{4}}{3.24 \times 10^{4}} = \frac{3.24 \times 10^{4}}{3.24$$

5.14 In a particular semiconductor material, $\mu_n = 1000 \text{ cm}^2/\text{V-s}$, $\mu_p = 600 \text{ cm}^2/\text{V-s}$, and $N_C = N_V = 10^{19} \text{ cm}^{-3}$. These parameters are independent of temperature. The measured conductivity of the intrinsic material is $\sigma = 10^{-6} (\Omega \text{-cm})^{-1}$ at T = 300 K. Find the conductivity at T = 500 K.

the conductivity at
$$T = 500 \text{ K}$$
.

 $O = e \left(\mu_n + \mu_p \right) n_i \left(\mu_n^2 - N_c N_V \exp \left(-\frac{\epsilon_g}{N_i} \right) \right)$

Conductivity

 $J = 1.6 \times 10^{-19} (400) (10^6) (10) = 6.4 \text{ A/cm}^2$

$$n_{i} = \frac{6}{e(\mu_{i} + \nu_{i})} = \frac{10^{2}}{(16 \times 10^{13})(1000 + 600)} = 3.1 \times 10^{3} / \text{cm}^{3}$$

$$E_{j} = \text{mt In} \left(\frac{N_{c} N_{V}}{n_{i}^{2}} \right) = (8.62 \times 10^{-5})(300) \ln \left(\frac{(10^{9})(10^{9})}{(3.9 \times 10^{9})^{2}} \right) = 1.15 \text{ eV}$$

$$n_{i} = \left(\frac{10^{19}}{(10^{19})} \right) \exp \left(\frac{-1.15}{(8.62 \times 10^{5})(500)} \right) = 2.56 \times 10^{36} / \text{cm}^{6}$$

$$n_{i} = \sqrt{2.56 \times 10^{36}} = 1.6 \times 10^{13} / \text{cm}^{3}$$

$$\sigma = \left(\frac{1.6 \times 10^{-19}}{(1000 + 600)} \right) \left(\frac{1.6 \times 10^{13}}{(1000 + 600)} \right) = \frac{4.09 \times 10^{-3}}{\Omega \cdot \text{cm}}$$

The steady-state electron distribution in silicon can be approximated by a linear function of x. The maximum electron concentration occurs at x = 0 and is $n(0) = 2 \times 10^{16}$ cm⁻³. At x = 0.012 cm, the electron concentration is 5×10^{15} cm⁻³. If the electron diffusion coefficient is $D_n = 27$ cm²/s, determine the electron diffusion current density.

$$J = eD_{n} \frac{dn}{dx} = eD_{n} \left(\frac{n(0) - n(0.012)}{\sigma - o.012}\right)$$

$$J = (1.6 \times 10^{-17}) \left(27\right) \left(\frac{(2 \times 10^{16}) - (5 \times 10^{18})}{\sigma - o.012}\right)$$

$$= (1.6 \times 10^{-19}) \left(27\right) \left(-1.25 \times 10^{18}\right)$$

$$= -5.4 \text{ A/cm}^{2}$$

5.36 The total current in a semiconductor is constant and equal to $J=-10\,\mathrm{A/cm^2}$. The total current is composed of a hole drift current and electron diffusion current. Assume that the hole concentration is a constant and equal to $10^{16}\,\mathrm{cm^{-3}}$ and assume that the electron concentration is given by $n(x)=2\times10^{15}e^{-x/L}\,\mathrm{cm^{-3}}$ where $L=15\,\mu\mathrm{m}$. The electron diffusion coefficient is $D_n=27\,\mathrm{cm^2/s}$ and the hole mobility is $\mu_p=420\,\mathrm{cm^2/V}$ -s. Calculate (a) the electron diffusion current density for x>0, (b) the hole drift current density for x>0, and (c) the required electric field for x>0.

$$J = e D_n \frac{d_n}{dx}$$

$$J = e D_n \frac{d \left[-2 \times 10^{15} e^{-x/L}\right]}{dx} = -2 \times 10^{15} \left(1.6 \times 10^{17}\right) \left(1.6 \times 10^{17}\right)$$

$$J_n = -5.76 e^{-C6.7 \times 10^{L}} A / cm^{L}$$

6.) For
$$x > 0$$

$$J = J_n + J_p = -10 \, \text{A/cm}^2$$

$$J_p = -10 - (-5.76e^{-(6.7 \times 10^2)} \times)$$

$$J_p = 5.76e^{-(6.7 \times 10^2)} \times -10 \, \text{A/cm}^2$$

For
$$x > 0$$

$$J_{p} = e_{p} M_{p} \in E$$

$$E = J_{p} = \frac{5.76e^{-(6.7 \times 10^{5})^{2}} - 10}{1.6 \times 10^{-17} (10^{16}) (420)}$$

$$E = 8.57e^{-(6.7 \times 10^{5})^{2}} - 14.88 \text{ V/cm}$$